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Date: February 20, 2002  
From: Mark C. Pickering  
Total Pages: 6  
User No: 14639  
C/M No: 072219-0278259  
To: Office of Initial Patent  
Examination  
Company: USPTO  
Phone No: (415) 983-1297  
Phone No: 703/308-1202  
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF  
 Inventors: Heikyung Min et al.

Appln. No.: 10 | 032,930  
 Series Code  $\uparrow$  | Serial No.  $\uparrow$

Filed: October 29, 2001

Title: APPARATUS AND METHOD FOR REDUCING SURFACE ZENER DRIFT USING TI-BASED METALLURGY

Date: February 20, 2002

Commissioner for Patents  
 Washington, D.C. 20231  
 Attn.: Office of Initial Patent Examination

Sir:

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- There is an error with respect to the following data which is

☒ incorrectly entered

and/or

☐ omitted

Error in

Correct data

1. ☒ Third Applicant's First Name

2. Robert Spence

Please see the attached copy of Declaration as filed.

- It is understood that the PTO no longer charges for correcting filing receipts even when the error is applicants' mistake, but if that is incorrect and a fee is due for this correction please charge our Deposit Account No. 03-3975 under Order No. 072219-0278259

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Dated: February 20, 2002

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72219 - 278059  
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/032,930	10/29/2001	2811	740	072219- 0278259 (P05108)	7	20	2

CONFIRMATION NO. 8013

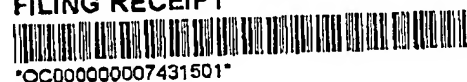
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#### Applicant(s)

Heikyung Min, Palo Alto, CA;  
 Steven Kurihara, San Jose, CA;  
~~Bob~~ Spence, Skelmorlie, UNITED KINGDOM;  
 ROBERT

Domestic Priority data as claimed by applicant

#### Foreign Applications

If Required, Foreign Filing License Granted 02/06/2002

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

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#### Title

Apparatus and method for reducing surface zener drift using Ti-based metallurgy

#### Preliminary Class

257

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